

<b>Notice of References Cited</b>	Application/Control No. 10/671,966		Applicant(s)/Patent Under Reexamination SCHNEIDER ET AL.	
	Examiner Michele C. Choi		Art Unit 2164	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,374,271	04-2002	Shimizu et al.	715/501.1
*	B	US-6,154,600	11-2000	Newman et al.	386/4
*	C	US-2004/0054627 A1	03-2004	Rutledge, David R.	705/050
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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